

Application Serial No. 10/594,174  
Response to Office Action dated February 18, 2009

RECEIVED  
CENTRAL FAX CENTER  
AUG 17 2009

PATENT  
Docket: CU-5102

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

INVENTOR: Hideshi Hattori et al. )  
APPLICANT: Dai Nippon Printing Co., Ltd ) EXAMINER: Kosson, Rosanne  
SERIAL NO: 10/594,174 )  
FILED: 09/26/2006 ) GROUP ART UNIT: 1652  
TITLE: METHOD FOR PRODUCING CELL CULTURE SUBSTRATE AND  
APPARATUS FOR PRODUCING CELL CULTURE SUBSTRATE  
Attorney CU-5102  
Docket No.

**Mail Stop Amendment**  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

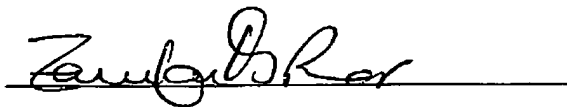
**REQUEST FOR 3-MONTH EXTENSION OF TIME**

Dear Sir:

With reference to the office action dated February 18, 2009 the applicants hereby request a three-month extension of the term for response, which thereby extends the end date of the current term from May 18, 2009 to August 18, 2009.

Please charge \$1110.00 to Deposit Account No. 12-0400 to cover the cost of the extension. No other fee is believed to be required. However, if this is not the case, please charge any additional fee or credit any overpayment to the same Deposit Account No. 12-0400.

Respectfully submitted,



Zareefa B. Flener, Pat. Reg. No. 52,896

Ladas & Parry, LLP  
224 South Michigan Avenue  
Suite 1600  
Chicago, IL 60604  
312-427-1300

08/17/2009 MNGUYEN 00000061 120400 10594174

02 FC:1253 1110.00 DA